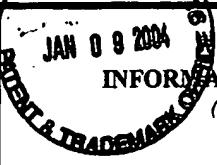


|  INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i> | | | | | Docket Number (Optional) 16772 | | Application Number 10/601,496 | |
|---------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----|--------------------------------------------------------------------------------------------------------------------|-------------------|------------|----------------------------------------------|-------------------------------------|-----------------------------------------|-----------|
| | | | | | Applicant(s) Takeshi Ozawa, et al. | | | |
| | | | | | Filing Date June 23, 2003 | Group Art Unit Unassigned | | |
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| | REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
| | | EP 1 256 310 A2 | 11/13/2002 | EPO | | | YES | NO |
| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | | |
| | | U.S. Patent Application Publication No. US 2002/0062061 A1, published May 23, 2002, issued to Kaneko et al. | | | | | | |
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